

**DOCKET NO: VSEA 02-01** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Daniel F. Downey et al.

Serial No:

09/996,446

Confirmation No:

2412

Filed:

November 28, 2001

For:

ATHERMAL ANNEALING WITH RAPID THERMAL

ANNEALING SYSTEM AND METHOD

Examiner:

Jermele M. Hollington

Art Unit:

2829

## **CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

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Sir:

## **AMENDMENT**

In response to the Final Office Action mailed July 13, 2004, please amend the above-identified application as follows.